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Sommario/riassunto

Adopting a novel approach, this book provides a unique "molecular perspective" on plasmonics, concisely presenting the fundamentals and applications in a way suitable for beginners entering this hot field as well as for experienced researchers and practitioners. It begins by introducing readers to the optical effects that occur at the nanoscale and particularly their modification in the presence of biomolecules, followed by a concise yet thorough overview of the different methods for the actual fabrication of nano-optical materials. Further chapters address the relevant nano-optics, as well a
